

Amendments to the Substitute Specification and Abstract

Please replace the second full paragraph on page 5 with the following amended paragraph:

A support unit 30, which is made of a solid, heat-conducting material, for example brass or platinum, and can be regarded as a housing part, encloses a core proper of laser unit 2, specifically a laser diode unit 34, in which laser beams are generated in the junction region between ~~the p-~~ layer and n-layer in a fashion known in the case of semiconductor lasers. The layer designated as laser diode unit 34 is, according to Figure 1, located directly on support unit 30. There follow, starting from laser diode unit 34, a first insulation layer 33, a piezoelement 32 as a pressure-generating element, and a second insulation layer 31, which is in contact on its other side with enclosing support unit 30. In this way, piezoelement 32 is electrically insulated.

Please replace the third full paragraph on page 8 with the following amended paragraph:

Figure 4 depicts laser unit 2 comprising the individual parts explained with reference to Figures 1A, 1B, 2, and 3. Thus support element 30 according to Figure 1 is arranged between frame element 50 having the semitransparent window and a mirror unit 80, an insulation layer 61 being present for electrical and thermal insulation between individual parts 80, 30, and 5650.

Please replace the Abstract with the following amended Abstract:

A light unit for generating light rays with differing wavelengths is disclosed. The light unit disclosed has a light source unit (34), a mirror unit (80), a carrier unit (30), an output window (50) comprising an opening (60) and a pressure generation unit (1232). The light source unit (34) and the pressure generation element (32) are contained in the carrier unit (30), which has a longitudinal axis (40) that runs substantially parallel to the generated light rays and the mirror unit (80) and the output window (50) are located at opposite ends of the carrier unit (30). In addition, the The pressure generation unit (32) generates a force that acts on the light source unit (34). The mirror unit (80) and/or the output window (50) can be displaced in relation to the carrier unit (30) and/or tilted in relation to the longitudinal axis (40) by at least one displacement element (52,..., 56), in conjunction with the force that is exerted on the light source unit (34) by the pressure generation element (32). This permits the wavelength of the light rays to be adjusted over a wide range.